## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Michael Hopkins et al.

Art Unit: Not yet assigned

Serial No. Not yet assigned

Examiner: Not yet assigned

Filed: March 2, 2004

For: A Method for Process Control of Semiconductor Manufacturing Equipment

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The citation of information on the attached Form PTO/SB/08 is made pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98. A copy of each cited item is enclosed.

The citation of this information does not constitute an admission of priority or that any cited item is available as a reference, or a waiver of any right the applicant may have under applicable statutes, Rules of Practice in patent cases, or otherwise.

Respectfully submitted,

David M. Krasnow Reg. No. 34,203

KILPATRICK STOCKTON LLP 1100 Peachtree Street Suite 2800 Atlanta, Georgia 30309-4530 (404) 815-6500

Our Docket: 54593/297131

Express Mail No.: EV 334683426 US Date of Deposit: March 2, 2004

ATLLIB02 22985.1

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number

Substitute for Form 1449/A/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary

Sheet of

Complete if Known				
Application Number	Not yet assignment			
Filing Date	March 2, 2004			
First Named Inventor	Michael Hopkins			
Group Art Unit	Not yet assigned			
Examiner Name	Not yet assigned			
Attorney Docket Number	54593/297131			

U.S. PATENT DOCUMENTS								
		U.S. Patent			Date of Publication of	Pages, Columns, Lines, Where Relevant Passages or Relevan Figures Appear		
Examiner (	Cite No. <sup>1</sup>	Number	Kind Code <sup>2</sup> (if known)		Cited Document MM-DD-YYYY			
	1	6,441,620	B1	Scanlan et al.	08-27-2002			
	2	5,479,340		Fox et al.	12/26/1995			
	3	5,926,690		Toprac et al.	07/20/1999			
	4	6,174,450	B1	Patrick et al.	01/16/2001			
	5	6,586,265	B1	Chiou et al.	07/01/2003			
	ļ					<del></del>		
	ļ							
•								
						····		
				<u> </u>				
						······································		

FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No.1	Foreign Patent Document  Kind Code <sup>3</sup> Office <sup>3</sup> Number <sup>4</sup> (if known)		Kind Code	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
	NO.	Office	Number	(ij known)	Applicant of Cited Document	141141-202-11111	Therevant ingules Appear	+
		† †						$\dagger \Box$
								$\vdash$
								<u> </u>
								$\sqcup$
<u> </u>								1
	L	<u> </u>						

Examiner			١ ـ .	
	•		Date	
Signature			Considered	

<sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent document, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached.